

Dressing Requirements & Instructions per Application



Recommended Dressing per Application

General:

Substrate matrices and quality requirements may vary and be different from customer to customer.

The ADT recommended dressing procedures are general / generic recommendations based on years of experience in the market place. They are a good starting point for each application.

Final optimization of the dressing procedure should be performed at the customer site in a production mode



Recommended Dressing per Application

Application - Plastic BGA

Most BGA type applications require no specific dressing. Customers are starting to dice on production wafers, some at top production feed rate and some by an override process.

<u>Blade Used</u> – For tape mounting – Metal Sintered – ADT Matrices –95, 29, 62, 02 For tapeless mounting – Metal Sintered – ADT Matrix 42 <u>Override recommendation:</u> Override media – Production BGA substrate

Recommended override parameters:-Spindle speed – Production speed 30-40Krpm Feed rate – Start at 10mm/sec going up by 5mm/sec increments, making 5x cuts at each feed rate, going up to production speed. Cut depth – Use production depth Index – Use substrate index









Application - QFN - H.E. - Lead / Tin (Matte) (Pb / Sn) coating

Blade used – Resin –E- & -T-series Dressing media – Silicon Carbide – 320 mesh Dressing media geometry – 90 x 25 x 3mm Dressing media P/N – 00767-0320-003

Dressing parameters	Process		
<u>v</u> ;	2"	3"	
Spindle speed – (Krpm)	22	15	
Feed rate – mm/sec	10 / 10x cuts	10 / 10x cuts	
	20 / 5x cuts	20 / 5x cuts	
	40 / 5x cuts	40 / 5x cuts	
	60 / 5x cuts	60 / 5x cuts	
	80 / 5x cuts	80 / 5x cuts	
Cut depth – (mm)	Production + 0.2	Production + 0.2	
Cut length – (Meters)	~1-1.5	~1-1.5	
Index –	2x blade Thick.	2x blade Thick.	





Note – Perform height only after the dressing process is completed

ADT = Dicing III Advanced Dicing Technologies



Application - QFN - H.E. - Nickel Palladium (Ni / Pd) coating

Blade used – <u>Resin – E- & -T- series</u> Dressing media – Silicon Carbide – 320 mesh Dressing media geometry – 90 x 25 x 3mm Dressing media P/N – 00767-0320-003

Dressing parameters	Process			
<u>v</u> ;	2"	3"		
Spindle speed – (Krpm)	22	15		
Feed rate – mm/sec	10 / 10x cuts	10 / 10x cuts		
	20 / 5x cuts	20 / 5x cuts		
	40 / 5x cuts	40 / 5x cuts		
	60 / 5x cuts	60 / 5x cuts		
	80 / 5x cuts	80 / 5x cuts		
Cut depth – (mm)	Production + 0.2	Production + 0.2		
Cut length – (Meters)	~1-1.5	~1-1.5		
Index –	2x blade Thick.	2x blade Thick.		



الحدة العدة الالدة المتدا المتدا	all a late a case and a reality
	a series and a series of the s
TILL FRANK CLI	TTTTTTTTTTTTT

Note – Perform height only after the dressing process is completed

Advanced Dicing Technologies



<u>Application</u> – Power QFN Blade used – <u>Resin –E- series</u> Dressing media – Silicon Carbide – 320 mesh Dressing media geometry – 90 x 25 x 5mm Dressing media P/N – 00767-0320-005

Dressing parameters	Process
	3"
Spindle speed – (Krpm)	12-16
Feed rate – mm/sec	10 / 10x cuts
	20 / 10x cuts
	40 / 10x cuts
Cut depth – (mm)	Production + 0.2
Cut length – (Meters)	~1-1.5
Index –	2x blade Thick.







<u>Application</u> – PCB (LED Packages)

Blade used – Nickel Serrated, 2" O.D. x "T", "V" & "Z" matrices x 10, 13, & 17mic. Grit x .003"-.008" thick Dressing media – Green Silicon Car. 600mesh Dressing media geometry - 90 x 25 x 2mm or 3mm Dressing media P/N – 767-0600-002 or -003





Dressing parameters:-	Process			
Spindle speed –	25-35Krpm			
Feed rate -	10mm/sec 3x cuts, 20mm/sec 3x cuts, 40mm/sec 3x cuts			
	60mm/sec 3x cuts, 80mm/sec 3x cuts, 100mm/sec 3cuts			
Cut depth -	Production + 0.2mm			
Cut length –	~0.5meter			
Index –	2x blade Thick.			





<u>Application</u> – Ceramic BGA Blade used - Resin, 2" or 4" O.D. X Matrices K or R x 45 – 75mic diamond grit x .006" - .020" thick Dressing media – Green Silicon Car. 600mesh Dressing media geometry - 90 x 25 x 2mm or 3mm Dressing media P/N – 767-0600-002 or -003



Dressing parameters:-	2" O.D.	4" O.D.		
Spindle speed –	25 – 30Krpm	8 – 12Krpm		
Feed rate –	2mm/sec 2x cuts, 4mm/sec 2x cuts, 6mm/sec 2x cuts			
	8mm/sec 2x cuts, 10mm/sec	2x cuts		
Cut depth -	Production + 0.2mm			
Cut length –	250mm			
Index –	Blade thickness x 2			





Glass Applications general:

The market faces many glass applications with different thickness and material variations.

The following are general dressing recommendations. For special glass coatings or surface finishes consult the factory.

Glass up to 1mm thick can be diced with both resin & metal Sintered blades. Glass over 1mm we recommend to use resin type blades.





Application – Glass using resinoid blades Blade used – Resin Matrices QUP, QKP & QIP x 2", 3" & 4" O.D 15-45mic. diamond grit x .003" - .020" thick Dressing media – Green Silicon Car. 600mesh – 320 for grits over 30mic Dressing media geometry - 90 x 25 x 2mm or 3mm or 5mm Dressing media P/N – 767-0600-002 or -003 or – 005



767-0320-003 or -005 - for over 30mic grit

	Glass thickness range							
Dressing parameters:-	Up to ().5mm	0.5 to 1mm		1 – 2mm		2 – 4mm	
Spindle Dia.	2"	4"	2"	4"	2"	4"	2"	4"
Spindle speed – Krpm	20-30	8-12	20-30	8-12	18-25	8-12	18-25	8-12
Feed rate - mm/sec,	2, 4, 6	x 2 cuts	2, 4 ,6 2	c 2 cuts	2, 4, 6,	x 2 cuts	1, 2, 3, 4,	5, 2 cuts
Cut depth - ^{cut / F.R}	Pro. Sub	.+0.2mm	Pro. Sub	.+0.2mm	Pro. Sub	.+0.2mm	Pro. Sub	.+0.2mm
Index –	Blade t	hick. x 2	Blade th	ick. x 2	Blade t	nick. x 2	Blade th	ick. x 2





Application – Glass using metal sintered blades Blade used – Sintered matrices –M55, -M96 x 2" O.D. 10, 13, 17, 25, 30mic. diamond grit x .003" - .010" thick Dressing media – Green Silicon Car. 600mesh Dressing media geometry - 90 x 25 x 2mm or 3mm or 5mm Dressing media P/N – 767-0600-002 or -003 or – 005

	Glass thickness range				
Dressing parameters:-	Up to 0.5mm	0.5 to 1mm			
Spindle Dia.	2"	2"			
Spindle speed – Krpm	20	20			
Feed rate - mm/sec,	2,3,4,5, 6 x 2 cuts	2, 4, 5, 6 x 2 cuts			
Cut depth -	Pro. Sub.+0.2mm	Pro. Sub.+0.2mm			
Index –	Blade thick. x 2	Blade thick. x 2			







Application – Hard Alumina Blade used – Resin Matrices KUP, RUP x 2", & 4" O.D 45 - 88mic. diamond grit x .006" - .020" thick Dressing media – Green Silicon Car. 320mesh Dressing media geometry - 90 x 25 x 2mm or 3mm or 5mm Dressing media P/N – 767-0320-002 or -003 or – 005

) thick	
UNICK	
5mm	
	0982 25KV 5990m

	Glass thickness range							
Dressing parameters:-	Up to ().5mm	0.5 to	1mm	1 – 3	2mm	2 –	4mm
Spindle Dia.	2"	4"	2"	4"	2"	4"	2"	4"
Spindle speed – Krpm	18-30	8-12	18-30	8-12	18-30	8-12	18-30	8-12
Feed rate - mm/sec,	2, 4, 6, 8	3 x 2 cuts	2, 4 ,6, 8	x 2 cuts	2, 4, 6, 8	3 x 2 cuts	2, 4, 6, 8	x 2 cuts
Cut depth - ^{cut / F.R}	Pro. Sub	.+0.2mm	Pro. Sub	.+0.2mm	Pro. Sub	.+0.2mm	Pro. Sub	.+0.2mm
Index –	Blade t	hick. x 2	Blade th	ick. x 2	Blade t	hick. x 2	Blade thi	ick. x 2

Note – Perform height only after the dressing process is completed

ADT = Dicing



Application – Quartz (SAW filters others) Blade used – Resinoid 2" – Matrices KUP, QUP x 30-45mic. grit x .006" - .012" thick Dressing media – Green Silicon Car. 600mesh Dressing media geometry - 90 x 25 x 2mm or 3mm Dressing media P/N – 767-0600-002 or -003

	Quartz thickness range			
Dressing parameters:-	0.2 - 0.5mm	0.5 to 1mm		
Spindle Dia.	2"	2"		
Spindle speed – Krpm	18 - 20	20 - 22		
Feed rate - mm/sec,	1, 2, 3, 4, 5, x 2 cuts	1, 2, 4, 5, x 2 cuts		
Cut depth -	Pro. Sub.+0.2mm	Pro. Sub.+0.2mm		
Index –	Blade thick. x 2	Blade thick. x 2		







Application – LiNb03 & LiTa03 Blade used - Nickel 2" O.D. x 3-6 & 4-8mic. Grit x .002"-.003" thick - Resinoid 2" – Matrices QUP, QKP & KUP x 15 & 20mic. grit x .003" - .006" thick Dressing media – For Nickel – Silicon carbide (Dark) – 600 mesh For Resinoid - Green Silicon Car. 600mesh Dressing media geometry - Ni. - 75 x 75 x 1mm, Resin - 90 x 25 x 2mm or 3mm Dressing media P/N – Ni. – 767-0000-001, Resin 767-0600-002 or -003

Dressing parameters:-	Nickel	Resinoid		
Substrate thickness	0.2 - 1mm	0.2 - 2mm		
Spindle Dia.	2"	2"		
Spindle speed – Krpm	30Krpm	25-30Krpm		
Feed rate - mm/sec,	2 x 10 cuts, 5x5 cuts & 8 x 1cut	2 x 2 cuts, 4 x 2 cuts, 8 x 2cuts		
Cut depth -	.002" .005" Pr.+ 0.2mm	Production + 0.2mm		
Index –	Blade thick. x 2	Blade thick. x 2		

Dicing

iced Dicing Technologie



Application – LTCC Blade used – Sintered 2" O.D. Matrices M94 & M50 x 15 - 35mic. Grit x .002"-.003"thick Resinoid 2" – Matrices QUP, QKP & KUP x 35-53mic. grit x .006" - .008" thick Dressing media – For Sintered – Green Silicon carbide 600 mesh

- For Resinoid - Green Silicon Car. 320 mesh

Dressing media geometry - 90 x 25 x 2mm or 3mm

Dressing media P/N – Sintered - 767-0600-002 or -003, Resin 767-0320-002 or -003

Dressing parameters:-M. Sintered Resinoid Substrate thickness 0.2 - 2mm 0.5 - 2mm Spindle Dia. 2" 2" Spindle speed – Krpm 32-38 28-30 Feed rate - mm/sec, 2 x10cuts. 4x5cuts & 6x 5cuts 5 x 5 cuts, 8 x5 cuts & 5 x 1 cut cut / F.R Cut depth -Pro. Sub.+0.2mm .002" .005" Pr.+ 0.2mm Index – Blade thick. x 2 Blade thick. x 2

Note – Perform height only after the dressing process is completed

Dicing

Advanced Dicing Technologies



Application – HTCC Blade used – Sintered – 2" O.D. Matrices M94 & M50 x 35-50mic. Grit x .005" - .008" thick Dressing media – Green Silicon Carbide – 320 mesh Dressing media geometry – 90 x 25 x 2 or 3mm Dressing media P/N – 00767-0320-002 or - 003

Dressing parameters	Process
Spindle speed –	20-30Krpm
Feed rate – mm/sec	5, 10, 15, 20, 25, 30 x 4 cuts per F.R.
Cut depth – (mm)	Production + 0.2mm
Cut length – (Meters)	0.6 meter
Index –	Blade thickness x 2









Application – Silicon wafers

Blade used – Nickel (Annular) 2" O.D. x 2-4, 3-6, 4-6mic. x .0012"-.002" thick Dressing media – Silicon Carbide (Dark) 600 mesh Dressing media geometry – 75 x 75 x 1mm Dressing media P/N – 767-0000-001

Dressing parameters:-	Step # 1	Step # 2	Step # 3	Step # 4
Spindle speed –	35-45Krpm	35-45Krpm	35-45Krpm	35-45Krpm
Feed rate - inch/sec	6"	.2"	.5"	On blank Sil. wafer Start at .1". cont. at
Cut depth -	.002"	Production + .002"	Production + .002"	.2" steps up to pro.
Cut length –	10 x 75=750mm	10 x 75=750mm	10 x 75=750mm	speed depending on cut quality
Index –	Blade Thick. X 2	Blade Thick. X 2	Blade Thick. X 2	Blade Thick. X 2

+ Cut depth = production depth + .001"





<u>Application</u> – Silicon on Glass Blade used – Resin – 2" O.D. x matrices QUP & QKP x 25-35mic. Grit x .006"-.010" thick Dressing media – Silicon Carbide – 600 mesh Dressing media geometry – 90 x 25 x 3 or 5mm Dressing media P/N – 00767-0600-003 or -005

Dressing parameters	Process
Spindle speed – (Krpm)	25-30
Feed rate – mm/sec	1 x 2 cuts, 2 x 2 cuts
	3 x 2 cuts, 5 x 2 cuts
Cut depth – (mm)	Production + 0.2mm
Cut length –	100mm
Index –	Blade Thickness x 2





<u>Application</u> – Tic – Magnetic head General:

This process involves thin blades with fine diamond grits. The quality criteria's are challenging and require unique dressing processes which are in house developed and are confidential for each customer.

The dressing process involves O.D. grinding on cylindrical grinders and than preliminary dressing on the dicing saws Using fine silicon carbide or AI. Oxide dressing medias and an override process on Tic. Blank material to confirm cut quality.

licing

The following recommended dressing procedures were developed and used successfully in ADT during blade optimization for some key magnetic head customers.



<u>Application</u> – Tic – Magnetic head Parting process

Blade used – Nickel – 4.3" O.D. x 3-6 & 4-6mic. Grit x special matrix x 0.060 - 0.100mm thick Dressing media – Silicon Carbide – 600 mesh Dressing media geometry - 90 x 25 x 3mm Dressing med

Dressing media P/N – 00	0767-0600-003	
Dressing parameters	Process	
Spindle speed – (Krpm)	9	
Feed rate – mm/sec x Cut depth – (mm)	2 x 5 cuts x 0.050 c. depth 2 x 2 cuts x 0.550 c. depth	
Cut length –	175mm	
Index –	Blade Thickness x 3	









Dressing – Silicon carbide 600 mesh

- Spindle 9Krpm
- 5x cuts at cut depth of 0.050mm
- 2x cuts at cut depth of 0.550mm
- Feed rate 2mm/sec

<u>Application</u> – Tic – Magnetic head <u>Process: Row Slicing</u>

Blade used – Nickel – 4.3" O.D. x 4–8, 10, 13mic. Grit x special matrix x 0.090 – 0.120mm thick Dressing media – Silicon Carbide – 600 mesh Dressing media geometry – 90 x 25 x 3mm Dressing media P/N – 00767-0600-003

Dressing parameters	Process
Spindle speed – (Krpm)	8 - 9
Feed rate – mm/sec x Cut depth – (mm)	2 x 6 cuts x 0.050 c. depth 2 x 2 cuts x 0.650 c. depth
Cut length –	200mm
Index –	Blade Thickness x 3







<u>Application</u> – Green ceramic

Green ceramic or unfired ceramic requires a different dicing mechanism of using nickel electroformed blades or Tungsten carbide saw blades. Both with nickel blades and with T. carbide saw blades no dressing is required.

No real diamond exposing is needed on nickel blades and on T. carbide blades any dressing will actually damage the blade buy loosing the sharpness of the teeth.

So directly dicing production substrate can be performed





<u>Application</u> – PZT (Ultrasound Sensors) Blade used – Nickel – 2" O.D. x 3-6 & 4-8mic. Grit x Low Dia.% x 0.020– 0.075mm thick Dressing media – Silicon Carbide – 600 mesh up to 3000 mesh Dressing media geometry – 90 x 25 x 3mm 75 x 75 x 1mm and others

Most PZT customers developed their own dressing process which is Usually confidential. The bellow are generic guide lines for a new user.

Dressing parameters	Process
Spindle speed – (Krpm)	20-30
Feed rate on Sil C mm/sec x Cut depth - (mm)	2 x 5 cuts x 0.050 c. depth 2 x 2 cuts x prod. c. depth
	Start at production F.R. (1-3mm/sec) x cut depth of 0.10mm. Change cut depth by steps of 0.050mm every 5 cuts till reaching production depth
Cut length – To be optimized	5 cuts in reaching production depth
Index – Blade Thick. x 3	

= Dicing

III Advanced Dicing Technologies